



_	Application No.	Applicant(s)
	09/471,777	SACHSE ET AL.
	Examiner	Art Unit
	Jean M Corrielus	2162

SEARCHED				
Class	Subclass	Date	Examiner	
709	223	2/28/2005	JMC	
709	224	2/28/2005	JMC	
709	527	2/28/2005	JMC	
709	614	2/28/2005	JMC	
709	318	2/28/2005	JMC	
707	10	2/28/2005	JMC	
707	202	2/28/2005	JMC	
707	201	2/28/2005	JMC	
717	174	2/28/2005	JMC	
717	178	2/28/2005	JMC	
714	4	2/28/2005	JMC	
714	43	2/28/2005	JMC	
714	48	2/28/2005	JMC	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
707	10	2/28/2005	JMC		
707	202	2/28/2005	JMC		
709	223	2/28/2005	JMC		
707		2/28/2005	JMC		

SEARCH NO (INCLUDING SEARCH	TES I STRATEGY)
	DATE	EXMR
WEST	2/28/2005	JMC
NPL (IEEE, ACM)	2/28/2005	JMC
·		